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Application Number	10728128
Filing Date	2003-12-04
First Named Inventor	Michael J. Hanrahan
Art Unit	2893
Examiner Name	Ahmed N. Sefer
Attorney Docket Number	043927/4054

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	4	5133755		1992-07-28	BREKKE	
	5	5917570		1999-06-29	BRYAN-BROWN et al.	
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2	GUO et al., "Fabrication of Thin-film Micropolarizer Arrays for Visible Imaging Polarimetry," Applied Optics 39 (10):1486-92 (2000)	<input type="checkbox"/>
3	LYONS, "The Light Fantastic," talk presented in March 1987, printed August 9, 2004 at http://www.austine.com/lyons.shtml	<input type="checkbox"/>
4	"Optical surfaces Based on Arrays of Microscopic Pillars," NASA's Jet Propulsion Laboratory, pp.1-2, Pasadena California, printed October 13, 2004 from http://www.nasatech.com/Briefs/Jan01/NPO20565.html	<input type="checkbox"/>
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